In The United States Patent And Trademark Office

Inventors:

Blaine R. Spady; John D. Heaton

Assignee:

Nanometrics Incorporated

Title:

Metrology/Inspection Positioning System

Serial No.:

09/458,123

Filing Date:

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Examiner:

Philip Sana Natividad

Group Art Unit:

2877

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COMMISSIONER FOR PATENTS

Washington, D. C. 20231

TECHNOLOGY CENTER 2800

RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In Response to the Office Action dated December 16, 2002, Applicants elect without traverse to have the invention of Group I, Claims 1-9, examined. Please withdraw from consideration Claims 10-14, which are drawn to the invention of Group II. Applicants reserve the right to seek examination of the invention of Group II in a divisional application.

It is believed that no fees are due. Nevertheless, if the Patent Office determines that an extension and/or other relief is required, Patent Owner petitions for any required relief including extensions of time and authorizes the Assistant Commissioner to charge the cost of such petitions and/or other fees due in connection with this filing of this document to <u>Deposit Account No. 50-2263</u> referencing NAN035 US.

Should the Examiner have any questions concerning this response, the Examiner is invited to call the undersigned at (408) 982-8200, ext. 2.

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CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number 703-872-9318 on January 13, 2003.

Attorney for Applicant(s)

Date of Signature

Respectfully submitted,

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